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Resonant MEMS for Gas Detection Based on the Measurements of Physical Properties of Gas Mixtures

(Invited Talk)

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Abstract—Principles of gas detection using either resonant microcantilevers or CMUTs without sensitive coating are presented. The different principles which have been tested for hydrogen detection are based on the use of electrical measurements to estimate physical gas properties (mass density, viscosity, sound velocity).

Keywords—resonant MEMS; CMUT; microcantilever; gas detection; resonant frequency; quality factor; time of flight; viscosity; mass density; sound velocity

I. INTRODUCTION

The presented results are part of the H2MEMS project which is dedicated to the monitoring of radioactive waste repository, especially for hydrogen measurement. Due to the hostility of the environment within the targeted application, the gas sensors have to be not only sensitive, but mostly reliable and durable. Selectivity is not a concern and it is not a major specification because only hydrogen concentration may change significantly in this environment.

The principle adopted in the framework of this project is based on the measurement of physical properties of the surrounding gas (measurements of mass density, viscosity or sound velocity) using resonant MEMS (microcantilever or capacitive micromachined ultrasonic transducer, CMUT). All the proposed principles require no chemical sensitive layer. The absence of the sensitive coating, which is subjected to sorption or redox phenomena in classical chemical sensors, leads to a more reliable and reversible behavior. However, the absence of selectivity, which is usually inherent to the presence of a sensitive coating, can be compensated by combining multiple physical properties measurements as it will be presented.

II. METHODS/RESULTS

As stated in the introduction, two kinds of resonant MEMS have been used in this project:

- Silicon microcantilevers with electromagnetic actuation and piezoresistive readout. The details of the manufacturing process based on bulk micromachining using SOI wafer can be found in [1]. The dimensions of the microcantilever used for the presented results are: 1mm x 1mm x 10 μ m.
- Silicon nitride capacitive micromachined ultrasonic transducers (CMUT). The fabrication process based on surface micromachining can be found in [2]. The dimensions of each membrane of the CMUT used for the presented results are: 32 μ m x 32 μ m x 450nm. Each CMUT is composed of thousands of membranes (the size of the chip is 8mm x 1mm).

In the case of the use of microcantilevers, the presented results are based on the measurement of both the resonant frequency and the quality factor, which allows to estimate simultaneously both the gas mass density and the gas viscosity [3]. An example of measurements obtained with different gases and the associated mass density and viscosity estimations are presented in Fig. 1.

In the case of the use of CMUT, the presented results are based on two different principles:

- The spectrum measurement of the impedance of the device is used, and based on an analytical modeling it has been proven that the measurement of the modulus of the admittance anti-resonance is more sensitive than the one at resonance and much more sensitive than the measurement of the frequency either at resonance or anti-resonance. This theoretical result has been confirmed by measurements (Fig. 2).
- The measurement of time of flight which depends on the sound velocity in the gas allows gas detection. The measurement of time of flight has been done using 2 face to face CMUTs and different methods: in the time domain with impulse as actuation [4] (Fig. 3) or in the

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spectrum domain by phase slope measurement [5] (Fig. 4).

III. CONCLUSIONS

In this two-pages abstract both the principles and examples of gas detection have been presented. In the invited talk more details will be given: sensitivity of the sensors, theoretical and measured limit of detection, example of the use of such non selective measurements to discriminate different binary mixtures.

Fig. 1. Resonant frequency measurements (top left) and quality factor measurements (top right) of silicon microcantilever for different gas mixtures (H_2 , He, CO_2 and CH_4 in N_2) at different concentrations (5%, 4%, 3%). Mass density (bottom left) and viscosity (bottom right) computed using these measurements.

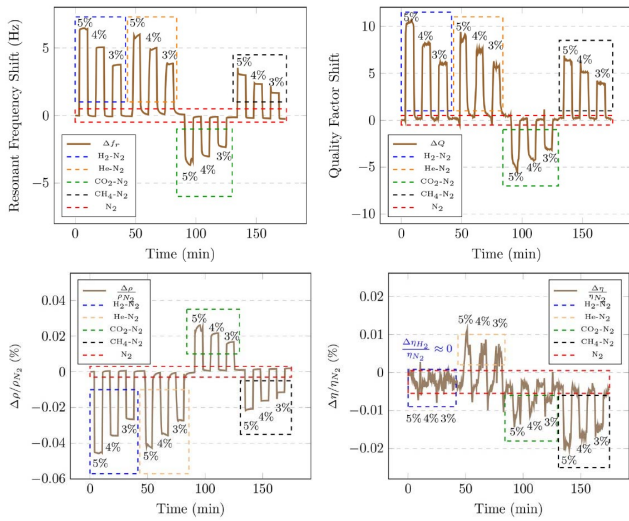


Fig. 2. Relative variation of different parameters extracted from the spectrum measurement of the admittance of CMUT during gas detection (80% of CO_2 in N_2 is used in order to better see the difference in the different parameters): Admittance at resonance (Y_{max}) or anti-resonance (Y_{min}), normalized frequency at resonance (x_r) or at anti-resonance (x_a).

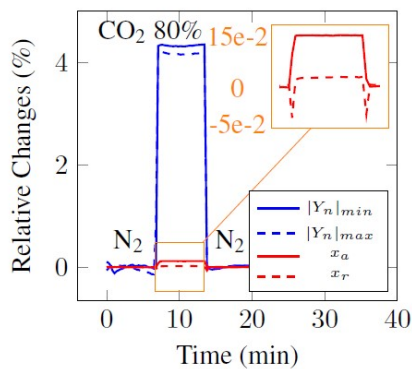


Fig. 3. Setup for the time of flight measurement in the time domain using two CMUTs (top). Time of flight measurement (bottom) during gas detection (H_2 in N_2) at different concentrations (5%, 4%, 3%, 2%).

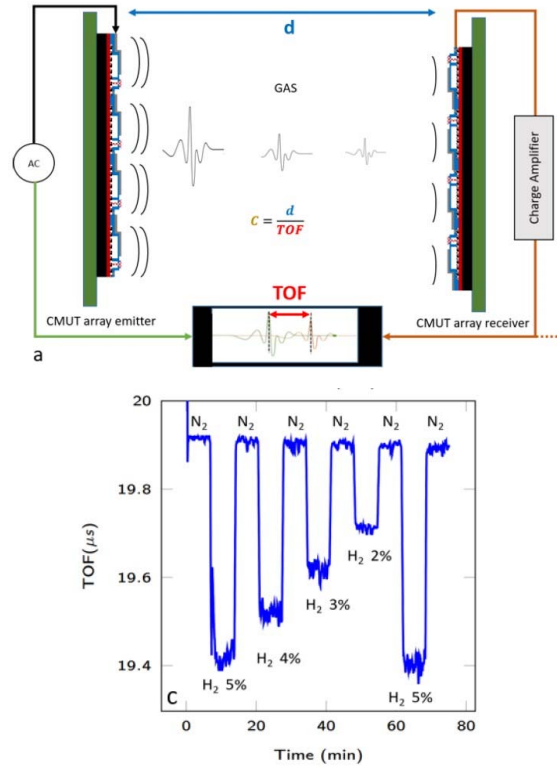
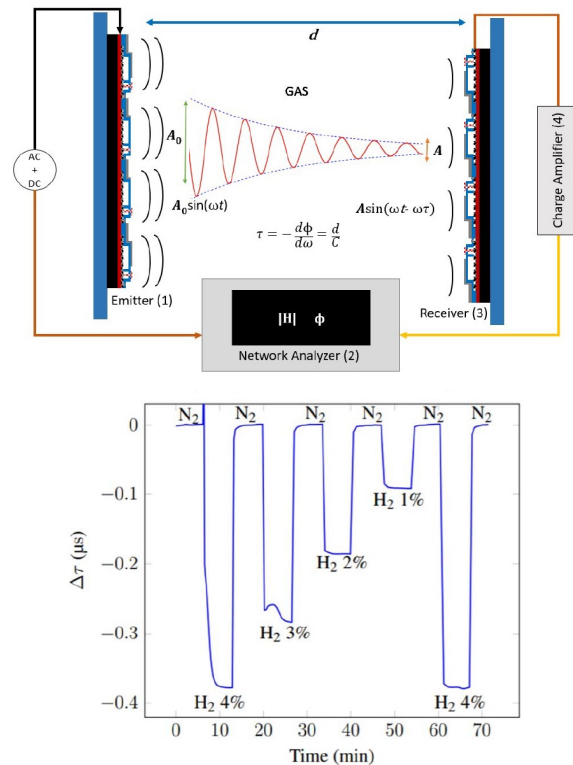


Fig. 4. Setup for the time of flight measurement in the frequency domain using two CMUTs (top). Time of flight measurement during gas detection (H_2 in N_2) at different concentrations (4%, 3%, 2%, 1%).



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